



**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 1 of 1

Complete if Known

| | |
|------------------------|--------------------|
| Application Number | 10/824,329 |
| Filing Date | 04/14/2004 |
| First Named Inventor | Yeshwanth Narendar |
| Art Unit | 2823 |
| Examiner Name | Julio J. Maldonado |
| Attorney Docket Number | 1075-E4371 |

U. S. PATENT DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Document Number | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
|--------------------|-----------------------|--|--------------------------------|--|---|
| | | Number-Kind Code ² (if known) | | | |
| | A | US- 6,296,716 B1 | 10/02/2001 | Haerle et al. | col 4, ln 4 - col 8, ln 6 |
| | B | US- 6,565,667 B2 | 05/20/2003 | Haerle et al. | col 4, ln 10 - col 9, ln 4 |
| | C | US- 6,723,437 B2 | 04/20/2004 | Haerle et al. | col 4, ln 13 - col 9, ln 2 |
| | D | US- | | | |
| | E | US- | | | |
| | F | US- | | | |
| | G | US- | | | |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |
| | N | US- | | | |
| | O | US- | | | |
| | P | US- | | | |
| | Q | US- | | | |
| | R | US- | | | |
| | S | US- | | | |

FOREIGN PATENT DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Foreign Patent Document | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear | T ⁴ |
|--------------------|-----------------------|---|--------------------------------|--|--|----------------|
| | | Country Code ³ Number ⁴ Kind Code ⁵ (if known) | | | | |
| | T | WO 02/09161 A2 | 01/31/2002 | SG Ceramics & Plastics, Inc. | pg 7, ln 18 - pg 7, ln 19 | |
| | U | | | | | |
| | V | | | | | |
| | W | | | | | |
| | X | | | | | |
| | Y | | | | | |

Examiner
Signature

Date

Considered

08/15/2005

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Substitute for form 1449A/PTO

Sheet 1 of 1
(use as many sheets as necessary)
Complete if Known

Application Number: NEW APPLICATION
Filing Date: HEREWITH
First Named Inventor: Yeshwanth Narendar
Group Art Unit:
Examiner Name:
Attorney Docket Number: 1075-E4371

U.S. PATENT DOCUMENTS

| Examiner Initials * | Cite No. 1 | U.S. Patent Document Number | Kind Code 2 (if known) | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document MM-DD-YYYY | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
|---------------------|------------|-----------------------------|------------------------|---|--|---|
| | AA | 6,093,644 | | Inaba et al. | 07/25/2000 | col 11 n 3 - col 15 n 30 |
| | AB | 6,277,194 | B | Thianderkvist et al. | 08/21/2001 | col 3 n 41 - col 11 n 31 |
| | AC | 6,066,572 | | Lu, et al. | 05/23/2000 | Fig 4 |
| | AD | | | | | |
| | AE | | | | | |
| | AF | | | | | |
| | AG | | | | | |
| | AH | | | | | |
| | AI | | | | | |
| | AJ | | | | | |

FOREIGN PATENT DOCUMENTS

| Examiner Initials * | Cite No. 1 | Foreign Patent Document Office 3 | Number | Kind Code 2 (if known) | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document MM-DD-YYYY | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear | T 4 |
|---------------------|------------|----------------------------------|--------|------------------------|---|--|---|--------------------------|
| | AK | | | | | | | <input type="checkbox"/> |
| | AL | | | | | | | <input type="checkbox"/> |
| | AM | | | | | | | <input type="checkbox"/> |
| | AN | | | | | | | <input type="checkbox"/> |
| | AO | | | | | | | <input type="checkbox"/> |

PUBLICATIONS

| Examiner Initials * | Cite No. 1 | Title of Publication | Date of Publication of Cited Document MM-DD-YYYY |
|---------------------|------------|--|--|
| | AW | Wolf, et al., "Silicon Processing for the VLSI ERA, Volume I", PROCESS TECHNOLOGY, 1986, Lattice Press, pages 213-216. | 1986 |
| | AX | Ghandi, Sorab K., VLSI Fabrication Principles, Silicon and Gallium Aresnide, 1983, John Wiley and Sons, pages 517-520. | 1983 |
| | AY | | |
| | AZ | | |

| | | | |
|--------------------|-------------------------|-----------------|------------|
| Examiner Signature | <i>Belief Maldonado</i> | Date Considered | 08/15/2005 |
|--------------------|-------------------------|-----------------|------------|

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Unique citation designation number. 2 See attached Kinds of U.S. Patent Documents. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.

SEND TO: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450